IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yasunobu TAGUSA

Application No.: 10/598,488

Confirmation No.: 6247

Filing or 371(c) Date: August 31, 2006

Title: METHOD FOR FABRICATING A

SEMICONDUCTOR DEVICE AND APPARATUS FOR INSPECTING A

SEMICONDUCTOR

Art Unit: 1792

Examiner: F. Hiteshew

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement issued on April 2, 2009, Applicant elects Group I, including claims 23-39 for prosecution in the present application. This election is made without traverse.

Applicant hereby reserves the right to file a Divisional Application to pursue prosecution of the non-elected claims.

Favorable consideration and prompt allowance of the present application are respectfully requested.

Application No. 10/598,488 April 23, 2009 Page 2 of 2

The Commissioner is authorized to charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 50-1353.

Respectfully submitted,

Dated: April 23, 2009

/Christopher A. Bennett, #46,710/ Attorneys for Applicant

Joseph R. Keating Registration No. 37,368

Christopher A. Bennett Registration No. 46,710

KEATING & BENNETT, LLP

1800 Alexander Bell Drive, Suite 200 Reston, VA 20191

Telephone: (571) 313-7440 Facsimile: (571) 313-7421